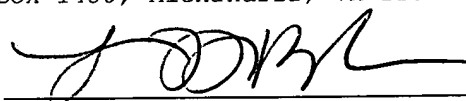




PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 2, 2004.*

  
Signature

Appl No. : 10/090,915 Confirmation No. 7688  
Applicant : Konstantin Holdermann  
Filed : March 5, 2002  
Title : ETCHING SOLUTION FOR WET CHEMICAL PYRAMIDAL TEXTURE  
ETCHING OF SILICON SURFACES  
TC/A.U. : 1765  
Examiner : Shamim Ahmed  
Docket No. : 47585/RAG/S969  
Customer No. : 23363

**COMMENTS ON REASONS FOR ALLOWANCE**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Post Office Box 7068  
Pasadena, CA 91109-7068  
December 2, 2004

Commissioner:

The Applicant believes the Examiner's stated reasons for allowance are unnecessary. The record as a whole makes clear the reasons for allowance and therefore a statement by the Examiner is not necessary or warranted. While the Applicant agrees that the claims are allowable, the Applicant does not acquiesce in the stated reasons for allowance, nor that patentability requires each stated feature as expressed by the Examiner.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP

By   
Robert A. Green  
Reg. No. 28,301  
626/795-9900

LES/mas  
LES PAS593124.1-\* -12/1/04 10:21 AM

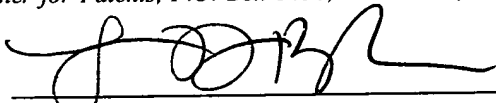


PATENT

Date of Notice  
of Allowance : September 15, 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 2, 2004.*

  
\_\_\_\_\_  
Signature

Applicant : Konstantin Holdermann Confirmation No. 7688  
Application No. : 10/090,915  
Filed : March 5, 2002  
Title : ETCHING SOLUTION FOR WET CHEMICAL PYRAMIDAL  
TEXTURE ETCHING OF SILICON SURFACES  
  
Grp./Div. : 1765  
Examiner : Shamim Ahmed  
  
Docket No. : 47585/RAG/S969

**STATEMENT OF THE SUBSTANCE OF TELEPHONIC INTERVIEW**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Post Office Box 7068  
Pasadena, CA 91109-7068  
December 2, 2004

Commissioner:

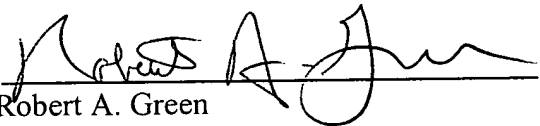
Applicant would like to thank the Examiner for taking the time to conduct a telephonic interview with applicant's representative on September 3, 2004. During that interview, an agreement was reached regarding certain amendments to the pending claims. Specifically, applicant authorized the Examiner's amendment of claims 1 and 7 in the following manner:

1. A free-standing silicon etching solution for [~~the~~] wet chemical pyramidal texture etching [~~of silicon surfaces~~] comprising: water, an alkaline reagent, isopropanol and aqueous alkaline ethylene glycol.

Appln No. 10/090,915  
Stmnt date December 2, 2004

7. A free-standing silicon etching solution for ~~the~~ wet chemical pyramidal texture etching ~~[of silicon surfaces]~~ comprising: water, sodium or potassium hydroxide, isopropanol and aqueous alkaline ethylene glycol.

Respectfully submitted,  
CHRISTIE, PARKER & HALE, LLP

By   
Robert A. Green  
Reg. No. 28,301  
626/795-9900

RAG/les

LES PASS96411.1-12/1/04 11:19 AM